IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant: Kawaguchi, et al. Case: 8033/ETCH

Serial No.: 10/777,026 Filed: February 11, 2004

Examiner: Tran, Binh X. Group Art Unit: 1765

Confirmation No.: 2197

Title: METHOD AND APPARATUS FOR REMOVING A HALOGEN-

CONTAINING RESIDUE

Mail Stop AF Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

SIR:

RESPONSE TO FINAL OFFICE ACTION DATED JULY 27, 2007

In response to the Advisory Action dated December 26, 2007 and the Final Office Action dated October 12, 2007, having a shortened statutory period for response set to expire on January 12, 2008, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although the Applicants believe that no fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 50-3562 for any fees, including extension of time fees, required to make this response timely and acceptable to the Office.